3D Printing of Ionic Conductors for High-Sensitivity Wearable Sensors

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**Supplementary Note**

**Modelling of capacitive sensors.** For a sensor using flat hydrogel film as electrodes, the overall capacitance \( C \) is determined by the overlapped area of two hydrogel electrodes \( A \) and the thickness of the VHB dielectric layer \( d_0 \),

\[
C = \varepsilon_0 \varepsilon_1 \frac{A}{d_0} \quad (1)
\]

where, \( \varepsilon_0 \) is the dielectric constant of vacuum \( (\varepsilon_0 = 8.85 \times 10^{-12} \text{ F m}^{-1}) \), \( \varepsilon_1 \) is the relative dielectric constant for the dielectric layer and its value is 4.7 for the VHB tape\(^1\). The initial thickness of the VHB dielectric layer \( d_0 \) is 500 \( \mu \text{m} \). Stretching or pressing the sensor will decrease the thickness of the dielectric layer \( d_0 \) and increase the overlapped area of the two hydrogel electrodes, consequently causing an increase in capacitance.

For structured sensor, each unit cell of the device is defined by four types of areal components, a real overlapping area \( A_{re} \times 4 \), an upper-suspended area \( A_{up} \times 2 \) (air gap located between top electrode and VHB dielectric layer), a lower-suspended area \( A_{low} \times 2 \) (air gap located between bottom electrode and VHB dielectric layer), and a fully suspended area \( A_{sus} \), as shown in Fig. 3c.

\[
A_{\text{unit}} = 4A_{re} + 2A_{up} + 2A_{low} + A_{sus} \quad (1)
\]

Therefore, the total capacitance of a unit cell \( (C_{\text{unit}}) \) in an array is composed of four types, a real overlapping capacitance \( C_{re} \times 4 \), a upper-suspended capacitance \( C_{up} \times 2 \), a lower-suspended capacitance \( C_{low} \times 2 \) and a fully suspended capacitance \( C_{sus} \). It is described as equation (2).

\[
C_{\text{unit}} = 4C_{re} + 2C_{up} + 2C_{low} + C_{sus} \quad (2)
\]

where \( C_{re} \) is the capacitance of the dielectric between two hydrogel electrodes given by

\[
C_{re} = \frac{A_{re}}{\varepsilon_0 \varepsilon_1 \frac{d_0}{A}} \quad (3)
\]

\( C_{up} \) is the capacitance of the upper-suspended portion given by

\[
\frac{1}{C_{up}} = \frac{1}{C_{d0}} + \frac{1}{C_{gap-up}} \quad (4)
\]

where, \( C_{d0} \) is the capacitance of the dielectric layer at the upper-suspended portion given by

\[
C_{d0} = \frac{A_{up}}{\varepsilon_0 \varepsilon_1 \frac{d_0}{A}} \quad (5)
\]

and \( C_{gap-up} \) is the capacitance of the air gap at the upper-suspended portion given by

\[
C_{gap-up} = \frac{A_{up}}{\varepsilon_0 \frac{d_1}{A}} \quad (6)
\]

where \( d_1 \) is the thickness of air gap, and in this work, its initial value is 200 \( \mu \text{m} \). Substituting (5) and (6) into (4), we obtain:
\[ C_{up} = \varepsilon_0 \varepsilon_1 \frac{A_{up}}{d_0 + \varepsilon_1 d_1} \]  

(7)

Similarly, the capacitance of the lower-suspended portion can be given by

\[ C_{low} = \varepsilon_0 \varepsilon_1 \frac{A_{low}}{d_0 + \varepsilon_1 d_2} \]  

(8)

where, \( d_2 \) is the thickness of air gap at the lower-suspended portion.

And \( C_{sus} \) is the capacitance of the fully suspended portion given by

\[ \frac{1}{C_{sus}} = \frac{1}{C_{d_0}} + \frac{1}{C_{gap-up}} + \frac{1}{C_{gap-low}} \]  

(9)

where \( C_{d_0} \) is the capacitance of the dielectric layer between two air gaps given by

\[ C_{d_0} = \varepsilon_0 \varepsilon_1 \frac{A_{sus}}{d_0} \]  

(10)

And \( C_{gap-up} \) and \( C_{gap-low} \) are the capacitances of the air gap located below and above the VHB dielectric layer at the fully suspended portion, respectively. They can be given by equations (11) and (12).

\[ C_{gap-up} = \varepsilon_0 \frac{A_{sus}}{d_1} \]  

(11)

\[ C_{gap-low} = \varepsilon_0 \frac{A_{sus}}{d_2} \]  

(12)

Substituting (10-12) into (9), we obtain:

\[ C_{sus} = \varepsilon_0 \varepsilon_1 \frac{A_{sus}}{d_0 + \varepsilon_1 d_1 + \varepsilon_1 d_2} \]  

(13)

Hence, the capacitance of an entire device with \( n \) sensing units is thus given by

\[ C = nC_{unit} = n\varepsilon_0 \varepsilon_1 \left( \frac{4A_{re}}{d_0} + \frac{2A_{up}}{d_0 + \varepsilon_1 d_1} + \frac{2A_{low}}{d_0 + \varepsilon_1 d_2} + \frac{A_{sus}}{d_0 + \varepsilon_1 d_1 + \varepsilon_1 d_2} \right) \times 10^3 \]  

(14)

Hence, for a sensor with the structural hydrogel films as electrodes, (the hydrogel film is structured with multi-parallel lines, and each line width and height is 200 \( \mu \)m), and 500-\( \mu \)m-thick VHB tape and air as the dielectric layer, the initial overall capacitance \( (C) \) can be expressed as follows equation (15).

\[ C = nC_{unit}^0 = n\varepsilon_0 (8A_{re} + 1.39A_{up} + 1.39A_{low} + 0.42A_{sus}) \]  

(15)

For structured sensor-1, a 1 cm\(^2\) square device is composed of 25 \times 25 sensing units \( (n=625) \), and every sensing unit is divided into four areal components of \( A_{re}=1\times10^{-8} \) m\(^2\), \( A_{up}=2\times10^{-8} \) m\(^2\), \( A_{low}=2\times10^{-8} \) m\(^2\), \( A_{sus}=4\times10^{-8} \) m\(^2\). Accordingly, its initial capacitance is calculated to be 3.96 pF, smaller than the prediction for
the planar sensor (8.31 pF). When the line-to-line spacing is 400 μm, a 1 cm$^2$ square sensor consists of $16 \times 16$ sensing units ($n=256$), and in each unit, $A_{re}=1 \times 10^{-8}$ m$^2$, $A_{up}=4 \times 10^{-8}$ m$^2$, $A_{low}=4 \times 10^{-8}$ m$^2$, and $A_{sus}=16 \times 10^{-8}$ m$^2$. The initial capacitance for this sensor (structured sensor-2) is calculated to be 2.75 pF.

When applying an external force to the sensors in horizontal or orthogonal directions, all four types of areal components will undoubtedly increase, and the thickness of dielectric layer, $d_0$ and air gaps, $d_1$ and $d_2$ will reduce to varying degrees, thus resulting in an increase in capacitance according to equation (14). Therefore, by monitoring the changes of capacitance $C$ of the sensors, strain and pressure can be detected.

**Supplementary Figures**

**Supplementary Fig. 1** Light transmittance of PAAm-PEGDA-280 in the visible region.

**Supplementary Fig. 2** Mechanical deformation of PAAm-PEGDA-280 hydrogel. The hydrogel is capable of withstanding mechanical deformations: twisted (a) and knotted (b) stretching, inhomogeneous drawing (c) and compressing (d).
Supplementary Fig. 3 Mechanical and time-dependent properties. a Compressive strain-stress curves for hydrogels with different molecular compositions. Time dependences of b resistance change and c water retention for hydrogels with different molecular compositions.

Supplementary Fig. 4 Representative resistance change of the PAAm-PEGDA-280 hydrogel film during stretching/releasing cycles of strain from 0 to 50%.
**Supplementary Fig. 5** Measured initial capacitance for planar sensor, structured sensor-1 and structured sensor-2.

**Supplementary Fig. 6** Response and relaxation time of the structured sensor-2 to application and release of external pressure loads.  

- **a** Response time to increased pressure is about 200 ms.  
- **b** Relaxation time to decreased pressure is about 500 ms.
Supplementary Fig. 7 Strain distribution for three kinds of sensors when bearing a pressure load of 2 kPa. (a) planar sensor, (b) structured sensor-1 and (c) structured sensor-2.

Supplementary Fig. 8 2D finite element simulations. a Von Mises stress and (b) strain distribution for hydrogel/PDMS/hydrogel when bearing a pressure load of 2 kPa.
Supplementary Fig. 9 (a) Pressure sensitivity of the hydrogel sensors with different line heights. (b) Plots of capacitance response as a function of time for different applied pressures. (c) The linear relationship between pressure sensitivity of the structured sensors with line-to-line spacing.
Supplementary Tables

Table 1. Optimized parameters for the printing of PAAm-PEGDA hydrogels using an Asiga Pico 2 printer.

<table>
<thead>
<tr>
<th>Build parameter</th>
<th>Value</th>
</tr>
</thead>
<tbody>
<tr>
<td>Slice thickness</td>
<td>0.025 mm</td>
</tr>
<tr>
<td>Burn-in layers</td>
<td>1 layer</td>
</tr>
<tr>
<td>Slides per layer</td>
<td>1</td>
</tr>
<tr>
<td>Burn-in exposure time</td>
<td>2.2 s</td>
</tr>
<tr>
<td>Exposure time</td>
<td>2.2 s</td>
</tr>
<tr>
<td>Led wavelength</td>
<td>405 nm</td>
</tr>
<tr>
<td>Pixel size</td>
<td>39 μm</td>
</tr>
</tbody>
</table>

Table 2. Main compositions of the formulations for ionically conductive hydrogels.

| Hydrogels     | Main compositions concentration (mol L⁻¹) | \( \frac{C_{\text{AAm}}:C_{\text{PEGDA}}}{m_{\text{MgCl}_2 + \text{H}_2\text{O}}} \) | \( m_{\text{total}} \) |
|---------------|------------------------------------------|-------------------------------------------------|
| PEGDA         | 0 : 0.1 : 2                              |                                  | 66.7                |
| PAAm-PEGDA-40 | 2.0 : 0.05 : 2                           | 40:1                              | 70.7                |
| PAAm-PEGDA-120| 3.0 : 0.025 : 2                          | 120:1                             | 72.7                |
| PAAm-PEGDA-200| 3.3 : 0.017 : 2                          | 200:1                             | 73.4                |
| PAAm-PEGDA-280| 3.5 : 0.0125 : 2                         | 280:1                             | 73.7                |
| PAAm-PEGDA-360| 3.6 : 0.01 : 2                           | 360:1                             | 73.9                |
| PAAm          | 4.0 : 0 : 2                              |                                  | 74.7                |
## Table 3. Comparison of pressure sensors in previous reports.

<table>
<thead>
<tr>
<th>Electrode</th>
<th>Dielectric layer</th>
<th>Sensitivity ((\text{kPa}^{-1}))</th>
<th>Reference</th>
</tr>
</thead>
<tbody>
<tr>
<td>ACC/PAA/alginate hydrogel</td>
<td>VHB tape</td>
<td>0.17</td>
<td>2</td>
</tr>
<tr>
<td>PAAm hydrogel</td>
<td>VHB tape</td>
<td>0.1</td>
<td>3</td>
</tr>
<tr>
<td>ITO/PET</td>
<td>PDMS film</td>
<td>0.02 (unstructured)</td>
<td>4</td>
</tr>
<tr>
<td></td>
<td></td>
<td>0.55 (pyramid structured)</td>
<td></td>
</tr>
<tr>
<td>Ag NW</td>
<td>Ecoflex</td>
<td>1.62×10⁻³</td>
<td>5</td>
</tr>
<tr>
<td>ITO/PET</td>
<td>Porous PDMS</td>
<td>0.26 kPa⁻¹, 0–0.33 kPa</td>
<td>6</td>
</tr>
<tr>
<td></td>
<td></td>
<td>0.01 kPa⁻¹, 0.33–250 kPa</td>
<td></td>
</tr>
<tr>
<td></td>
<td></td>
<td>0.9×10⁻³ kPa⁻¹, 250–1 MPa</td>
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<tr>
<td>CNT</td>
<td>Ecoflex</td>
<td>0.59</td>
<td>7</td>
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<tr>
<td>SBS/Ag NPs</td>
<td>Kevlar fiber</td>
<td>0.21</td>
<td>8</td>
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<tr>
<td>Conductive Fabrics</td>
<td>microporous silicone</td>
<td>1.21×10⁻²</td>
<td>9</td>
</tr>
<tr>
<td>Graphene</td>
<td>PDMS/SUB/Air</td>
<td>6.55×10⁻²</td>
<td>10</td>
</tr>
<tr>
<td>Graphene</td>
<td>Porous Nylon</td>
<td>0.33</td>
<td>11</td>
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<tr>
<td>Graphene</td>
<td>GO foam</td>
<td>0.8 kPa⁻¹, 0–1.0 kPa</td>
<td>12</td>
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<tr>
<td></td>
<td></td>
<td>0.15 kPa⁻¹, 1.0–4.0 kPa</td>
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<tr>
<td>PEDOT:PSS</td>
<td>PDMS/Silica bead (500 nm)</td>
<td>1.0</td>
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<tr>
<td>Grid-structured hydrogel</td>
<td>PE</td>
<td>0.45</td>
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<tr>
<td>Ionogel</td>
<td>PDMS</td>
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<tr>
<td>ITO/PET</td>
<td>Porous PDMS</td>
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<tr>
<td>Graphite</td>
<td>PDMS</td>
<td>0.62</td>
<td>17</td>
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<tr>
<td>AgNWs</td>
<td>Microstructured ionic gel</td>
<td>54.3 kPa⁻¹, 0–0.5 kPa</td>
<td>18</td>
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<tr>
<td>Nafion</td>
<td>Air</td>
<td>5 nF kPa⁻¹, 0–5 kPa</td>
<td>19</td>
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<tr>
<td></td>
<td></td>
<td>0.15 nF kPa⁻¹, 10–30 kPa</td>
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</tr>
<tr>
<td>Ag</td>
<td>Ecoflex</td>
<td>1.45×10⁻³</td>
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<tr>
<td>AgNWs-healable PU</td>
<td>Graphene-healable PU</td>
<td>1.9</td>
<td>21</td>
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<tr>
<td>Type of Hydrogel</td>
<td>Type</td>
<td>VHB</td>
<td>Stress</td>
</tr>
<tr>
<td>----------------------------</td>
<td>-------</td>
<td>-----</td>
<td>---------</td>
</tr>
<tr>
<td>Line-structured hydrogel</td>
<td>VHB</td>
<td></td>
<td>0.84 kPa$^{-1}$</td>
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<tr>
<td>3D-mesh hydrogel</td>
<td>VHB</td>
<td></td>
<td>0.91 kPa$^{-1}$</td>
</tr>
</tbody>
</table>
Reference: